

Notice of References Cited	Application/Control No. 10/594,283		Applicant(s)/Patent Under Reexamination PENALVA, JOAQUIN ESPUELA	
	Examiner Peter Y. Choi		Art Unit 1794	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0031687	02-2003	Falder et al.	424/400
*	B	US-2003/0170453	09-2003	Foss et al.	428/373
	C	US-			
	D	US-			
	E	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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